

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Application No.: New Rule 53(b) Divisional of
U.S. Application No. 09/736,423

Filed: August 27, 2003

Docket No.: 108157.01

For: MASK PRODUCING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/736,423, filed December 15, 2000, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,


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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108157.01		APPLICATION NO. New Rule 53(b) Divisional of U.S. Application No. 09/736,423	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Kenji NISHI			
				FILING DATE August 27, 2003		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
		4,748,478	05/31/1988	Kyoichi SUWA et al.			
		5,477,304	12/19/1995	Kenji NISHI			
		5,593,800	01/14/1997	Hidehiko FUJIOKA et al.			
		6,204,912	03/2001	TSUCHIYA et al.			
		2002/0187406 A1	12/2002	MAGOME et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		JP-61-180275 (w/ abstract)	08/12/1986	Japan			
		JP-63-18352 (w/ abstract)	01/26/1988	Japan			
		JP-63-312636	12/21/1988	Japan			
		JP-2-139911 (w/ abstract)	05/29/1990	Japan			
		JP-2-143513 (w/ abstract)	06/01/1990	Japan			
		JP-6-132195 (w/ abstract)	05/13/1994	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							